

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: RUSU et al.

Attorney Docket No.: LAM1P180/P1170X

Application No.: 10/737,022

Examiner: Unassigned

Filed: December 15, 2003

Group: 1763

Title: HIGH ASPECT RATIO ETCH USING

MODULATION OF RF POWERS OF VARIOUS

FREQUENCIES

Confirmation No.: 5595

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on August 1, 2005 in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

REQUEST FOR STATUS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicants hereby request status of the above-referenced patent application. application was filed on December 15, 2003 and no response has been received as of this date.

Respectfully submitted,

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